

PATENT  
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE  
IN RE DIVISIONAL APPLICATION OF

APPLICANT: SIEBERT ET AL - 2 DIVISIONAL  
PARENT SERIAL NO.: 09/716,708 EXAMINER: S. RAO  
PARENT FILED: NOVEMBER 20, 2000 GROUP: 2814  
TITLE: EPITAXIALLY COATED SEMICONDUCTOR WAFER AND  
PROCESS FOR PRODUCING IT

INFORMATION DISCLOSURE STATEMENT

ATTN: MAIL STOP DIVISIONAL PATENT APPLICATION  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Enclosed herewith is a copy of a Submission of an  
Information Disclosure Statement of Dr. Wolfgang Staudacher  
filed in the Parent U.S. Patent Application Serial No.  
09/716,708 on November 20, 2000. Also enclosed is a copy of  
the IDS of Dr. Staudacher, along with the Form PTO-1449. Also  
enclosed is a copy of the Notice of Reference Cited  
PTO-Form 892 sent by the Patent Examiner in the Parent U.S.  
Patent Application Serial No. 09/716,708.

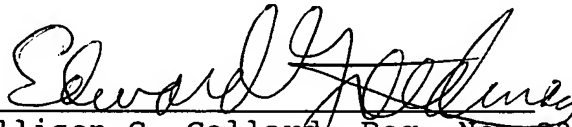
Because copies of each of these cited prior art references can be formed in the Parent U.S. Patent Application Serial No. 09/716,708, no copies are enclosed herewith.

Entry and consideration of this IDS is respectfully requested.

Respectfully submitted,

Wolfgang Siebert et al - 2 DIV.

COLLARD & ROE, P.C.  
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Roslyn, New York 11576  
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ERF:djp

  
Allison C. Collard, Reg. No. 22,532  
Edward R. Freedman, Reg.No. 26,048  
Attorneys for Applicants

Enclosures: Submission of an Information Disclosure Statement  
IDS, PTO 1449, PTO 892

I hereby certify that this correspondence is being deposited with the United States Postal Service as "Express Mail Post Office to Addressee" service under 37 CFR 1. 10, Mailing Label No. 9755566831, on the date: DECEMBER 9, 2003, and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

  
Maria Guastella

PATENT  
UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: SIEBERT ET AL 2

TITLE: EPITAXIALLY COATED SEMICONDUCTOR WAFER AND PROCESS FOR  
PRODUCING IT

SUBMISSION OF INFORMATION DISCLOSURE STATEMENT  
OF DR. WOLFGANG STAUDACHER

ATT: BOX PATENT APPLICATION  
Assistant Commissioner for Patents  
Washington, D.C. 20231

COPY

Dear Sir:

Applicants wish to bring to the attention of the Patent Examiner the attached Information Disclosure Statement, duly signed by Dr. Wolfgang Staudacher and the seven (7) references listed on the enclosed Form PTO-1449 and attached thereto.

The relevance of these references is that they are cited in the present patent application and may be material to the examination of the application.

It is respectfully requested that this Information Disclosure Statement be considered and placed into the application file.

Respectfully submitted,

Dr. Wolfgang SIEBERT ET AL 2

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1077 Northern Boulevard  
Roslyn, New York 11576  
(516) 365-9802

\_\_\_\_\_  
Allison C. Collard, Reg. No. 22,532  
Edward R. Freedman, Reg. No. 26,048  
Attorneys for Applicants

Encl: 1) Information Disclosure Statement Of Dr. Wolfgang Staudacher  
2) PTO-form 1449 w/copies of 7 references

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:  
ASSISTANT COMMISSIONER OF PATENTS, Washington, D.C. 20231, on November 20, 2000.

\_\_\_\_\_  
Lisa L. Vulpis

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of  
SIEBERT ET AL

Serial Number 09/116,708  
Filed: NOV. 20, 2000

Group Art Unit:

For: EPITAXIALLY COATED SEMICONDUCTOR WAFER AND PROCESS FOR  
PRODUCING IT

Information Disclosure Statement

Honorable Commissioner of Patents and Trademarks  
Washington, D.C. 20231

Sir or Madam:

I, Wolfgang Staudacher, associated with the preparation and prosecution of the above-identified application, residing at Seebauerstraße 4, 81735 München, Germany, wish to call the attention of the Patent Examiner to the references enumerated on the enclosed PTO Form-1449.

I believe the documents enumerated on the enclosed Form PTO-1449 and attached thereto, are cited in the enclosed application and may be material to the examination of the application.

Therefore, it is respectfully requested that the foregoing Information Disclosure Statement be considered by the Examiner and incorporated into the file of this application.

I wish to comment as follows concerning the prior art references enumerated on PTO Form-1449:

EP 0 684 634 is already in English language.

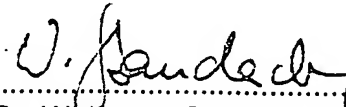
EP 0 711 854 is already in English language.

H. M. Liaw and J. W. Rose, Epitaxial Silicon Technology, Academic Press Inc., Orlando, Florida, 1986, p. 71-73 is already in English language.

For DE 198 33 257 an English Derwent Abstract is enclosed.

For DE 199 05 737 an English Derwent Abstract is enclosed.

Signed this 8<sup>th</sup> day of November, 2000

  
Dr. Wolfgang Staudacher

FORM PTO-1449  
(REV. 7-80)U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICE

ATTY. DOCKET NO. : 579940

SERIAL NO.

## LIST OF REFERENCES CITED BY APPLICANT

APPLICANT : Siebert et al.

(Use several sheets if necessary)

FILING DATE:

GROUP:

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

## FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	AL	0711 854	5/15/96	Europe				
	AM	0684 634	11/29/95	Europe				
	AN	199 05 737	8/31/00	Germany				
	AO	198 33 257	9/30/99	Germany				
	AP							

## OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

	AR		English Derwent Abstract AN 2000-579981 [55]
			corresp. to DE 199 05 737
	AS		English Derwent Abstract AN 1999-519699 [44]
			corresp. to DE 198 33 257
	AT		H.M. Liaw, J.W. Rose, Epitaxial Silicon Technology,
			Academic Press Inc., Orlando, Florida, 1986, p. 71-73

EXAMINER

DATE CONSIDERED

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

**Notice of References Cited**

Application/Control No.

09/716,708

Applicant(s)/Patent Under  
Reexamination  
SIEBERT ET AL.

Examiner

Steven H. Rao

Art Unit

2814

Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6284384	09-2001	Wilson et al.	428/450
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.